Application No.: 09/741,072

Docket No.: OBLON3457-C

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AUG 0 1 2007

Examiner: NGUYEN, DUNG V

Group Art Unit: 3723

In re PATENT APPLICATION of
Applicants: Lin et. al)

Serial No.: 09/741,072)

Filed: December 21, 2000)

For: WAFER POLISHING PAD)

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir,

In response to the Office Action dated April 18, 2002, please enter the amendments as below and consider the following remarks.